



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Frank JANSEN

Serial No.: 10/712,495

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Examiner: Howard E. Abramowitz

Group Art Unit: 1762

Attorney Docket: M02A430

Confirmation No.: 8327

Title: Atomic Layer Deposition Process and Apparatus

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SIR:

**RESPONSE TO FINAL OFFICE ACTION**

In response to the Final Office Action of 8 November 2005, please accept the following response.